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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Meikei Jeong et al.

Examiner: Tu Tu V. Ho

Serial No: 10/799,380

Art Unit: 2818

Filed: March 12, 2004

Docket: YOR920030394US2
(16963Z)For: CMOS ON HYBRID SUBSTRATE
WITH DIFFERENT CRYSTAL
ORIENTATIONS USING SILICON-
TO-SILICON DIRECT WAFER BONDING

Dated: September 14, 2005

Confirmation No. 7287

Mailstop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450RESPONSE UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated June 14, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: September 14, 2005



Leslie S. Szivos, Ph.D.